

IN THE SPECIFICATION

Please amend the paragraph at page 28, line 25 to page 29, line 6, as follows:

However, if a flow rate of CF₄ becomes unnecessarily large, all parts in the plasma processing apparatus may be rusted. Therefore, the ratio of flow rate of oxygen to that of CF₄ during the dry cleaning process is preferably not less than ~~700 seem / 1 seem~~ 1 sccm/700 sccm (about 0.14 %) but not greater than ~~700 seem / 50 seem~~ 50 sccm/700 sccm (about 7.1 %), and more preferably not less than ~~700 seem / 2 seem~~ 2 sccm/700 sccm (about 0.29 %) but not greater than ~~700 seem / 10 seem~~ 10 sccm/700 sccm (about 1.4 %).